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PATENT 8022-1080

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Morio TAKAHASHI Conf. 7300

Application No. 10/516,821 Group 2874

Filed December 7, 2004 Examiner H. Tran

THERMO-OPTIC PHASE SHIFTER AND MANUFACTURING METHOD OF THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449. JP 01-158413 has previously been cited in the Information Disclosure Statement of December 7, 2004.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in the corresponding Japanese Application Serial No. 2002-190531, filed June 28, 2002. A copy of the Japanese Official Action in which they were cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. An English translation of the enclosed portion is also attached hereto.

Docket No. 8022-1080 Appln. No. 10/516,821

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch, Reg. No. 17,355

745 South 23rd Street Arlington, VA 22202 Telephone (703) 521-2297 Telefax (703) 685-0573

(703) 979-4709

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December 4, 2006

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	JP 11-	-109157	04/23/1999	Japan	Japan			Yes	X X	
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		HORINO, Masaya et International Journal	al.: "Development	of Prototype	Micromechani	cal Optical		ISME		

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

DATE CONSIDERED

EXAMINER:

^{*} Abstract provided for the Examiner's convenience